




PATENT  
Docket No. 20067/OPP030889US

**IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE**

Applicant(s): Gyung-Su-Cho  
Serial No.: 10/676,645  
Filed: October 1, 2003  
For: "Semiconductor Device and a  
Fabrication Method Thereof"  
Group Art Unit: 2811  
Examiner: Unknown

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) **March 8, 2004**  
)  
)   
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**INFORMATION DISCLOSURE STATEMENT**

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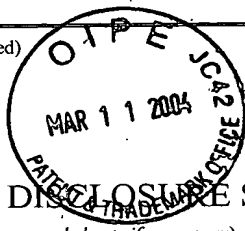
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March 8, 2004

Form PTO-1449 (Modified)

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20067/OPP030889US

Serial No.

10/676,645

Applicant

Gyung-Su Cho

Filing Date

October 1, 2003

Group Art Unit

Unknown

## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

## U.S. PATENT DOCUMENTS

*EXAMINER INITIALS		DOCUMENT NUMBER	ISSUE DATE	INVENTOR(S)	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A01	6,239,494	5/29/2001	Besser et al.			
	A02	6,376,353	4/23/2002	Zhou et al.			
	A03	6,400,026	6/4/2002	Andou et al.			
	A04						
	A05						
	A06						
	A07						
	A08						
	A09						
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	A18						
	A19						
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	A21						
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EXAMINER

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